



1374.43386X00 *DPK*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. WADA, et al.
Serial No.: 10/765,917
Filed: JANUARY 29, 2004
For: FABRICATION METHOD OF SEMICONDUCTOR
INTEGRATED CIRCUIT DEVICE
Group: 3729
Examiner: Paul D. Kim
Confirm. No: 4104

AMENDMENT

Mail Stop: AMEND – NO FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 18, 2006

Sir:

In response to the Office Action mailed October 18, 2006, please amend the
above-identified application as listed below and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.